

	Type	L #	Hits	Search Text
1	BRS	L1	29	(schedul\$4 and ((greatest or tact or takt or cycle or longest or largest or maximum or highest) near5 (time or duration or period or interval))) and (semiconductor\$1 or wafer\$1 or substrate\$1).ti,ab.
2	BRS	L2	42	(((tact or takt) near5 time)) and (schedul\$5 or synchroni\$6)
3	BRS	L3	81	(((tact or takt) near5 time)) and (semiconductor\$1 or wafer\$1 or substrate\$1).ti,ab.) and (((tact or takt) near5 time)) and (manufactur\$3 or factory or factories).ti,ab.)
4	BRS	L4	22090	(wafer\$1 with chamber\$1)
5	BRS	L5	6	((wafer\$1 with chamber\$1)) and common adj tim\$4
6	BRS	L6	47	((wafer\$1 with chamber\$1)) and synchro\$ adj tim\$4
7	BRS	L7	128	((wafer\$1 with chamber\$1)) and synchro\$ near2 tim\$4
8	BRS	L8	22	((wafer\$1 with chamber\$1)) and synchro\$ adj (process\$3)
9	BRS	L9	109	((wafer\$1 with chamber\$1)) and synchro\$ near2 (process\$3)
10	BRS	L10	205	((wafer\$1 with chamber\$1)) and synchro\$ near2 (move\$1 or moving or movement\$1)
11	BRS	L11	19	((wafer\$1 with chamber\$1)) and synchro\$ near2 (transport\$3)
12	BRS	L12	181	((schedul\$4 and ((greatest or tact or takt or cycle or longest or largest or maximum or highest) near5 (time or duration or period or interval))) and (semiconductor\$1 or wafer\$1 or substrate\$1).ti,ab.) and ((wafer\$1 with chamber\$1))
13	BRS	L13	107	(((tact or takt) near5 time)) and (semiconductor\$1 or wafer\$1 or substrate\$1).ti,ab.) and (((tact or takt) near5 time)) and (manufactur\$3 or factory or factories).ti,ab.)

	DBs	Time Stamp	C o m m e n t s	E r r o r D e f i n i t i o	Errors
1	EPO; JPO; DERWENT; IBM_TDB	2004/09/09 12:29		0	
2	EPO; JPO; DERWENT; IBM_TDB	2004/09/09 12:29		0	
3	EPO; JPO; DERWENT; IBM_TDB	2004/09/09 12:37		0	
4	USPAT; US-PGPUB	2004/09/09 12:30		0	
5	USPAT; US-PGPUB	2004/09/09 12:38		0	
6	USPAT; US-PGPUB	2004/09/09 12:38		0	
7	USPAT; US-PGPUB	2004/09/09 12:32		0	
8	USPAT; US-PGPUB	2004/09/09 12:38		0	
9	USPAT; US-PGPUB	2004/09/09 12:39		0	
10	USPAT; US-PGPUB	2004/09/09 12:39		0	
11	USPAT; US-PGPUB	2004/09/09 12:39		0	
12	USPAT; US-PGPUB	2004/09/09 12:35		0	
13	USPAT; US-PGPUB	2004/09/09 12:37		0	

	Type	L #	Hits	Search Text
14	BRS	L14	0	((wafer\$1 with chamber\$1)) and common adj tim\$4
15	BRS	L15	0	((wafer\$1 with chamber\$1)) and synchro\$ adj tim\$4
16	BRS	L16	2	((wafer\$1 with chamber\$1)) and synchro\$ adj (process\$3)
17	BRS	L17	5	((wafer\$1 with chamber\$1)) and synchro\$ near2 (process\$3)
18	BRS	L18	7	((wafer\$1 with chamber\$1)) and synchro\$ near2 (move\$1 or moving or movement\$1)
19	BRS	L19	0	((wafer\$1 with chamber\$1)) and synchro\$ near2 (transport\$3)

	DBs	Time Stamp	C o m m e n t s	E r r o r D e f i n i t i o	Errors
14	EPO; JPO; DERWENT; IBM_TDB	2004/09/09 12:38		0	
15	EPO; JPO; DERWENT; IBM_TDB	2004/09/09 12:38		0	
16	EPO; JPO; DERWENT; IBM_TDB	2004/09/09 12:38		0	
17	EPO; JPO; DERWENT; IBM_TDB	2004/09/09 12:39		0	
18	EPO; JPO; DERWENT; IBM_TDB	2004/09/09 12:39		0	
19	EPO; JPO; DERWENT; IBM_TDB	2004/09/09 12:39		0	